



P23757.A03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Takashi IIZUKA et al.

Group Art Unit: 2861

Appln. No. : 10/643,900

Examiner:

Filed : August 20, 2003

For : MANUFACTURING METHOD OF SCANNING OPTICAL SYSTEM

PRELIMINARY AMENDMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to the examination on the merits of the above-identified patent application, the Examiner is respectfully requested to amend the claims as follows.